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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 207.010-US)In the Application of: **LUTZ ET AL.**) Group  
) Art Unit: 2814Serial No: **10/698,258**)  
) BeforeFiled: **OCTOBER 31, 2003**) Examiner: **Le, Dung Anh**  
)  
)Title: **ANTI-STICKTION TECHNIQUE FOR THIN FILM  
AND WAFER-BONDED ENCAPSULATED  
MICROELECTROMECHANICAL SYSTEMS**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Michiko Sato  
(name of person signing certificate)

Michiko Sato  
Signature

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**AMENDMENT AND REPLY OF DECEMBER 20, 2004**

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Dear Sir:

Kindly amend the application as follows: